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Facsimile: 972-917-4418  
Phone: 972-917-5355

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of  
Zhu et al.

Docket Number: TI-36284

Serial No.: 10/772,709

Art Unit: 2814

Filed: February 5, 2004

Examiner: Phat X Cao

For: HIGH DENSITY VERTICALLY STACKED SEMICONDUCTOR DEVICE

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___ INFORMAL DRAWINGS	___ REPLY BRIEF (IN TRIPLICATE) (# Pages)
___ CONTINUATION APP'N (# Pages)	<input checked="" type="checkbox"/> ELECTION (1 pg)
NAME OF INVENTOR(S): <b>Zhu et al.</b>	
RECEIPT DATE & SERIAL NO.: Serial No.: <b>10/772,709</b> Conf. No: <b>5626</b>	
TITLE OF INVENTION: <b>Hish Density Vertically Stacked...</b>	
TI FILE NO.: <b>TI-36284</b>	DEPOSIT ACCT. NO.: <b>20-0668</b>
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Texas Instruments Incorporated  
PO Box 655474, M/S 3999  
Dallas, TX 75265

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
PATENT APPLICATION

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Appl. No. : 10/772,709  
Applicant : Jianbai Zhu et al.  
Filed : February 5, 2004  
TC/A.U. : 2814  
Examiner : Phat X Cao

Confirmation No. 5626

Docket No. : TI-36284  
Customer No. : 23494

Commissioner for Patents  
P. O. Box 1450  
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7-18-2005

Jackie McBride  
Jackie McBride

ELECTION

Sir:

In response to the Examiner's restriction requirement mailed June 24, 2005, applicants elect Group I, claims 1-15, for prosecution purposes.

Texas Instruments Incorporated  
P. O. Box 655474, M/S 3999  
Dallas, Texas 75265  
(972) 917-5355

Respectfully submitted,

Yingsheng Tung  
Yingsheng Tung  
Attorney for Applicants  
Reg. No. 52,305